

Application/Control No. 09/944,456	Applicant(s)/Patent Under Reexamination YEH, SHOW-WAY			
Examiner	Art Unit			
Burton S. Mullins	2834	Page 1 of 1		

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	Α	US-4,093,880	06-1978	Teal, Benjiman R.	310/24
	В	US-4,767,955	08-1988	McDaniel, Michael A.	310/20
	С	US-5,394,131	02-1995	Lungu, Cornelius	335/229
	D	US-5,644,177	07-1997	Guckel et al.	310/40MM
	E	US-5,876,187	03-1999	Forster et al.	417/322
	F	US-5,990,473	11-1999	Dickey et al.	250/231.13
	G	US-5,955,817	09-1999	Dhuler et al.	310/307
	Н	US-6,002,184	12-1999	Delson et al.	310/14
	1	US-6,328,903	12-2001	Vernon, Sr., George E.	216/2
	J	US-6,463,664	10-2002	Bieg, Lothar F.	33/1M
	К	US-6,171,886	01-2001	Ghosh et al.	438/73
	L	US-			
	М	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	0					
	Р					
	Q					
	R					
	S					
	Т					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Michel et al. "Mechatronic Micro Devices" International Symposium on Micromechatronics and Human Science, 1999.
	v	
	w	
	х	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).) Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.